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Attorney's Docket No: 013921-000025



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: Linthicum et al.

Serial No.: 10/633,952

Confirmation No.: 5174

Filed: August 4, 2003

Group Art Unit: 2815

Examiner: Jackson

Title: Methods of Fabricating Gallium Nitride
Microelectronic Layers on Silicon Layers
and Gallium Nitride Microelectronic
Structures Formed Thereby

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

RESPONSE UNDER 37 C.F.R. § 1.111

Sir:

This paper is being filed in response to the Office Action mailed May 7, 2004, having a reply due date of June 7, 2004. The Applicants hereby petition the Commissioner for Patents to extend the time for response by four (4) months to at least October 7, 2004. The appropriate fee for a Petition for Extension of Time is enclosed. A Supplemental Information Disclosure Statement is also enclosed. Reconsideration of the application is respectfully requested in light of this response.

There are no **Amendments to the Specification**.

Amendments to the Claims begin on page 2 of this paper.

Remarks/Arguments begin on page 4 of this paper.

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